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TRANSMITTAL FORM (to be used for all correspondence after initial filing)	Application Number	10/689,958
	Filing Date	October 20, 2003
	First Named Inventor	Cem Basceri
	Art Unit	2812
	Examiner Name	Unknown
Total Number of Pages in This Submission	Attorney Docket Number	MI22-2417

ENCLOSURES (Check all that apply)		
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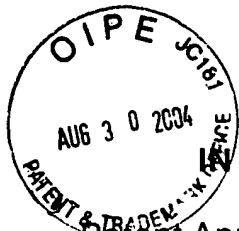
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EV372461155



THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent Application Serial No. 10/689,958
Filing Date October 20, 2003
Inventor Cem Basceri
Assignee Micron Technology, Inc.
Group Art Unit 2812
Examiner Unknown
Attorney Docket No. MI22-2417
Customer No. 021567
Title: Methods of Forming Conductive Metal Silicides by Reaction of Metal with
Silicon

INFORMATION DISCLOSURE STATEMENT

References -- See Attached Form PTO-1449

The attached form PTO-1449 is submitted in compliance with 37 CFR §1.56. Pursuant to 1276 OG 55, August 5, 2003, no copies of cited U.S. patents or U.S. patent application publications are included, as the date of filing of this patent application occurs after June 30, 2003. Copies of all other references are attached. No admission is made regarding whether all the listed references are prior art.

Citation of the referenced art is respectfully requested.

This Information Disclosure Statement is being filed before the mailing date of a first Office Action. There, no fee is believed to be required. However, in the event that a fee is required for filing this Information Disclosure Statement, please charge the fee specified under 37 C.F.R. § 1.17(p) to Deposit Account No. 23-0925.


Respectfully submitted,

Dated: _____

8/30/04

By: _____

Mark S. Matkin
Reg. No. 32,268

Form PTO-1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. MI22-2417		SERIAL NO. 10/689,958	
 <p>LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)</p>				APPLICANT: Cem Basceri			
				FILING DATE October 20, 2003		GROUP 2812	
U.S. PATENT DOCUMENTS							
*Examiner's Initials	AA	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
	AA	4,086,074	04/78	Minot et al.			
	AB	4,622,735	11/86	Shibata			
	AC	4,683,645	08/87	Naguib et al.			
	AD	4,693,910	09/87	Nakajima et al.			
	AE	4,766,090	08/88	Coquin et al.			
	AF	5,099,304	03/92	Takemura et al.			
	AG	5,236,865	08/93	Sandhu et al.			
	AH	5,444,024	08/95	Anjum et al.			
	AI	5,470,784	11/95	Anjum et al.			
FOREIGN PATENT DOCUMENTS							
		Document Number	Date	Country	Class	Subclass	Translation
							Yes No
	AJ						
	AK						
	AL						
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)							
	AM	ABSTRACT: Basceri et al., Atomic Layer Deposition for Nanoscale CU Metalization, 10 pages (pre-April 2004).					
	AN	En et al., Plasma immersion ion implantation reactor design considerations for oxide charging, 85 SURFACE AND COATINGS TECHNOLOGY 64-69 (1966).					
	AO	Ku et al., The Application of Ion Beam Mixing, Doped Silicide, and Rapid Thermal Processing of Self-Aligned Silicide Technology, 137 J. Electrochem. Soc. No. 2, pp. 728-740 (February 1990).					
EXAMINER		DATE CONSIDERED					
<p>*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.</p>							

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U.S. PATENT DOCUMENTS							
*Examiner's Initials	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate	
AA	5,670,298	09/97	Hur				
AB	6,037,239	03/00	Jennings				
AC	6,096,621	08/00	Jennings				
AD	6,130,140	10/00	Gonzalez				
AE	6,133,105	10/00	Chen et al.				
AF	6,133,116	10/00	Kim et al.				
AG	6,177,235 B1	01/01	Francou et al.				
AH	6,277,709 B1	08/01	Wang et al.				
AI	6,277,728 B1	08/01	Ahn et al.				

FOREIGN PATENT DOCUMENTS							
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					Yes	No	
AJ							
AK							
AL							

OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)			
	AM		ABSTRACT: How to Eliminate Voiding in Porous-Low-k Dielectrics and The Mechanism of Void Formation; Lin et al.; 4 pages
	AN		COB Stack DRAM Cell Technology beyond 100 nm Technology Node; Yongjik Park & Kinam Kim; pp. 349.1 - 349.3;
	AO		Rubin et al., Shallow-Junction Diode Formation by implantation of Arsenic and Boron Through Titanium-Silicide Films and ..., 17 IEEE Transactions on Electron Devices, No. 1, pp. 183-190 (January 1990).
EXAMINER		DATE CONSIDERED	

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*Examiner's Initials	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate	
	AA	6,440,793 B1	08/02	Divakaruni et al.			
	AB	6,465,325 B2	10/02	Ridley et al.			
	AC	6,720,638 B2	04/04	Tran			
	AD	6,780,728 B2	08/04	Tran			
	AE	6,156,674	12/00	Li et al.			
	AF	6,281,100 B1	08/01	Yin et al.			
	AG	6,291,363 B1	09/01	Yin et al.			
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	AI	6,383,723 B1	05/02	Iyer et al.			

FOREIGN PATENT DOCUMENTS							
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	AL						

OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)			
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	AA	2001/0006759 A1	07/01	Shipley, Jr. et al.			
	AB	2002/0076879 A1	06/02	Lee et al.			
	AC	2002/0196651 A1	12/02	Weis			
	AD	2003/0013272 A1	01/03	Hong et al.			
	AE						
	AF						
	AG						
	AH						
	AI						

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U.S. PATENT DOCUMENTS							
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AA	10/609,311		Yataes			06/03	
AB	10/655,997		Daley			09/03	
AC	10/690,029		Derderian et al.			10/03	
AD	10/882,118		Sandhu et al.			04/04	
AE	10/879,367		Blalock et al.			06/04	
AF							
AG							
AH							
AI							

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